

Title: METHOD AND APPARATUS FOR CONTROLLING DOPANT
CONCENTRATION DURING BPSG FILM DEPOSITION TO REDUCE NITRIDE
CONSUMPTION

Inventor(s): MUKAI, et al.

Application No./Atty. Docket No.: 4887.P518 / 5047/TCG/PMD/LE

Serial No.: 09/910,583

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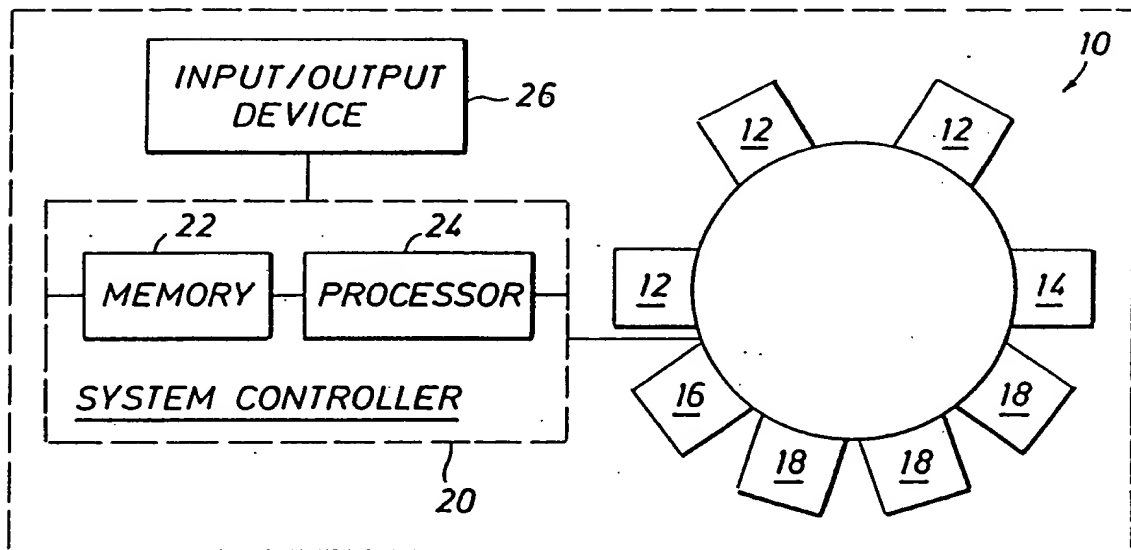
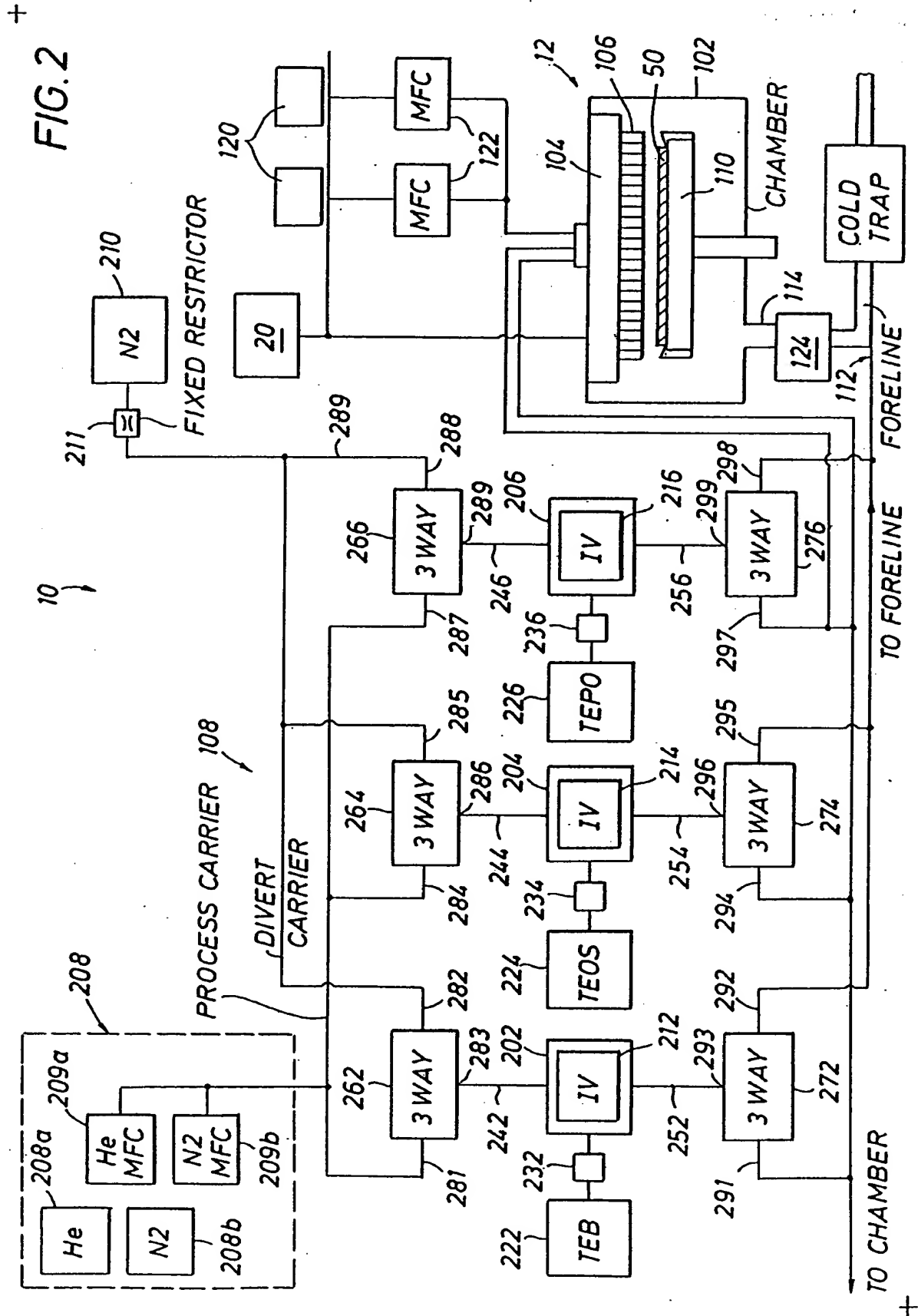


FIG. 1



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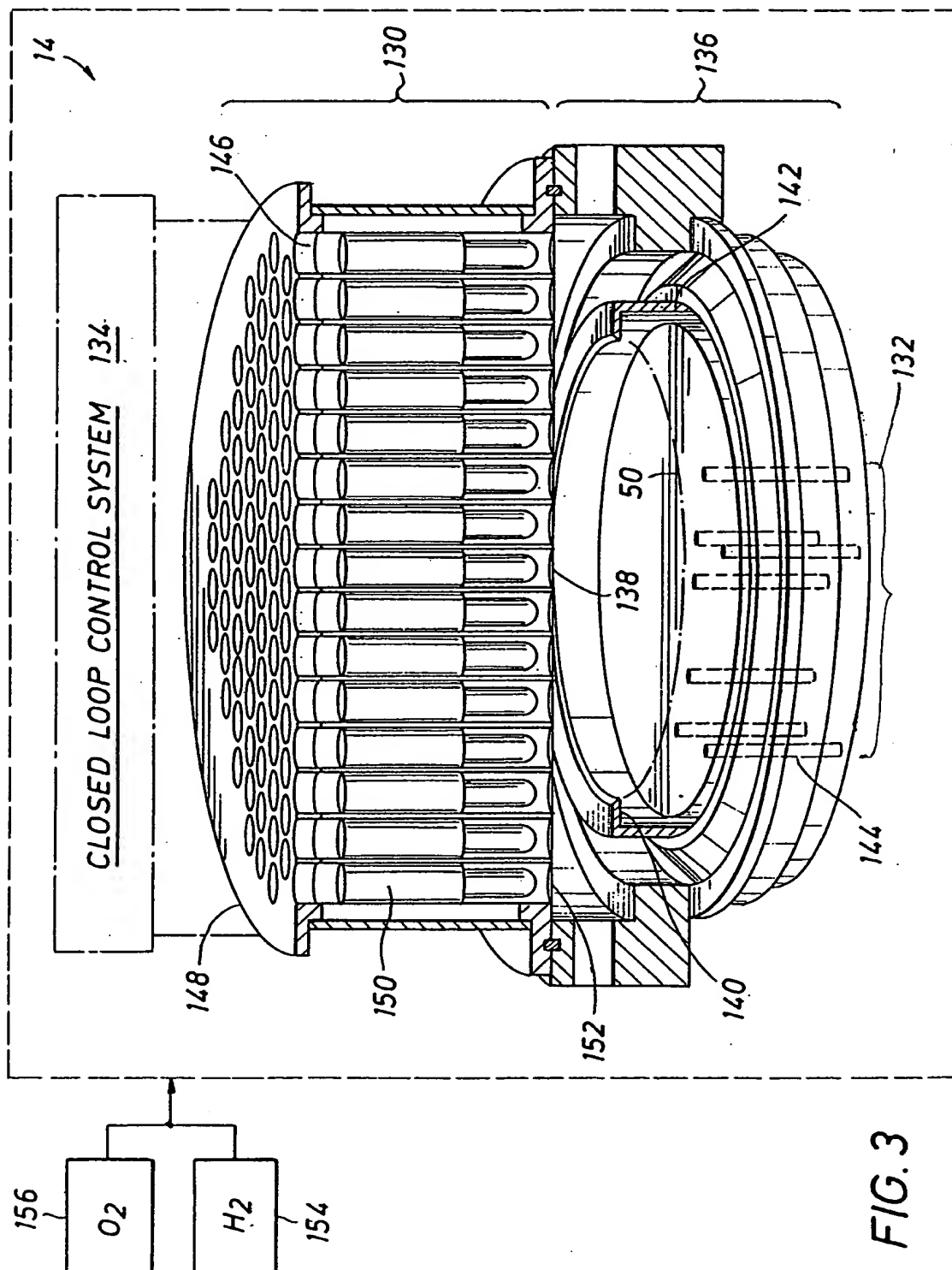
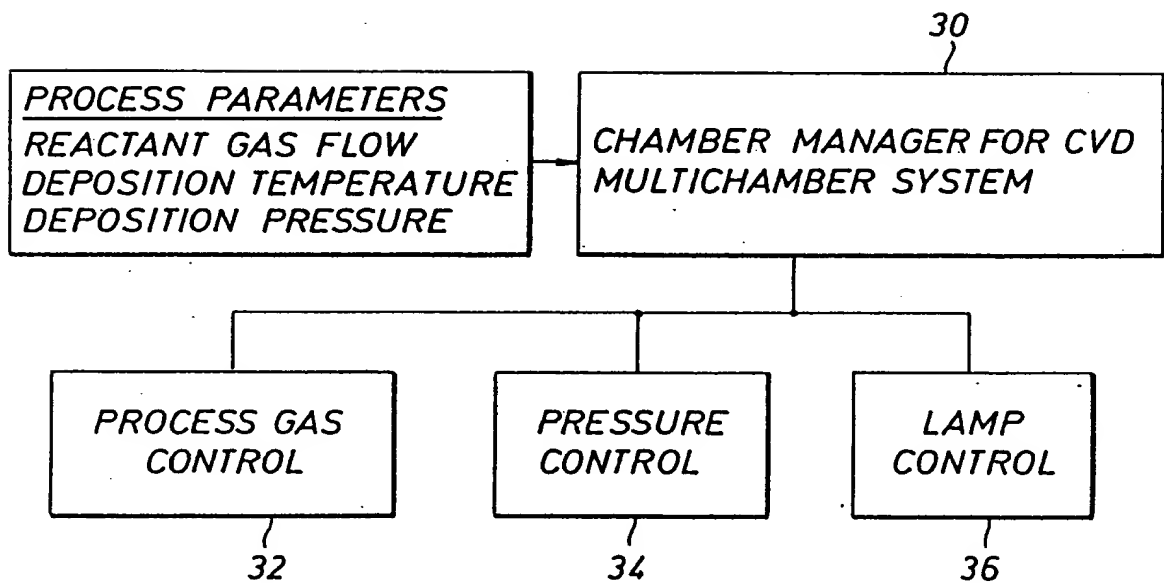


FIG. 4



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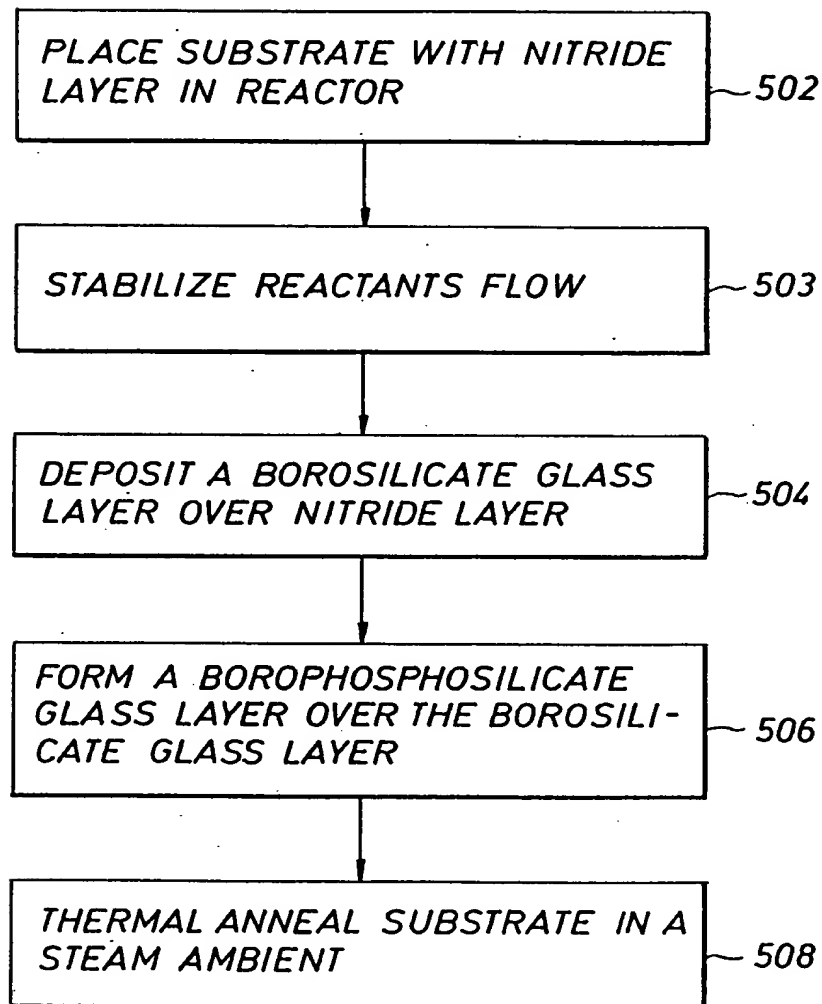


FIG. 5

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FIG. 6

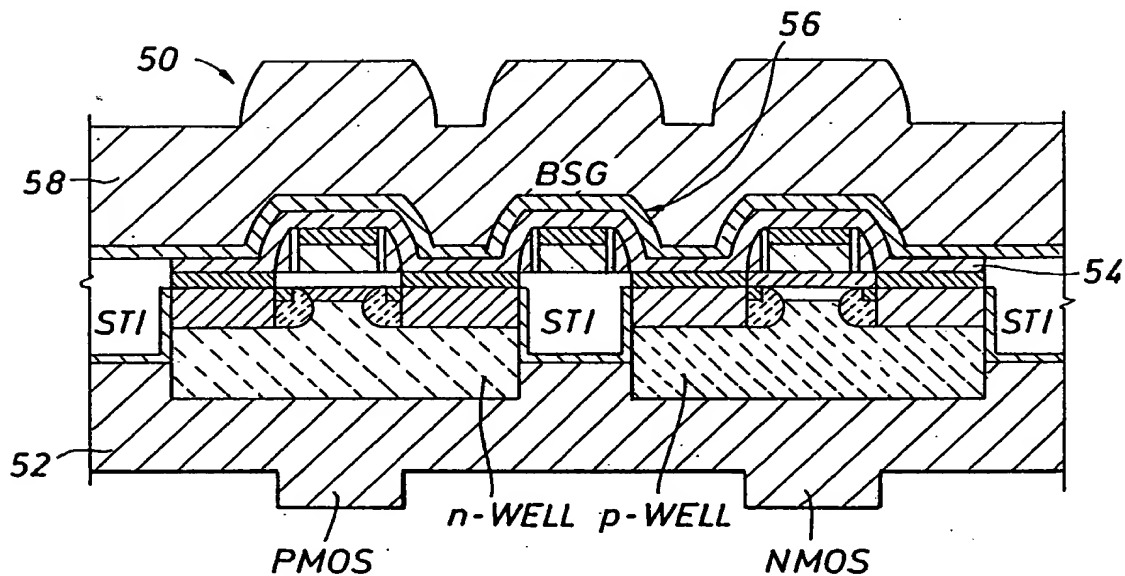


FIG. 7

